



520.35237VX3

IFC 81763
C.C.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

T. KAJI, et al.

Application No.:

10/052,538

Filed:

January 23, 2002

For:

PLASMA PROCESSING APPARATUS PROCESSING
METHOD

Art Unit:

1763

Examiner:

A. M. Crowell

AMENDMENT

MS: AMENDMENTS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 28, 2006

Sir:

In response to the Office Action dated December 28, 2005, the period of response for which extension is requested by the attached Petition for Extension of Time, please amend the above-identified application as listed below and set forth on the following pages:

Amendments to the Claims and

Remarks are included following the amendments.